



Attorney's Docket No.: 10417-039002 / F51-125462M/SW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Toshimitsu Taniguchi et al.      Art Unit : 2811  
Serial No. : 10/806,610      Examiner : Samuel A. Gebremariam  
Filed : March 23, 2004  
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING  
THEREOF

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Prior to examination, please amend the application as indicated on the following pages.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

February 28, 2006

Date of Deposit

Signature

Rose Syracuse

Typed or Printed Name of Person Signing Certificate